



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Manabu NAKAMURA et al.**

Group Art Unit: **2891**

Application Number: **10/659,748**

Examiner: **Bradley Smith**

Filed: **September 11, 2003**

Confirmation Number: **3468**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE  
HAVING GATE OR TUNNEL INSULATION FILM**

Attorney Docket Number: **031140**

Customer Number: **38834**

**RESPONSE UNDER 37 C.F.R. §1.116**  
**EXPEDITED PROCESSING REQUESTED**

**MAIL STOP AF**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

March 16, 2006

Sir:

In response to the Office Action dated November 18, 2005, the response date of which having been extended by one month to March 18, 2006, Applicants submit the following remarks, which begin on page 2 of this paper.

OK  
to E-mail  
TSKS  
3/5/06